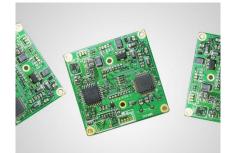
Chemical-resistant fluororesin coating material CYTOP™

CYTOP	Transparency	Repellency	Water proof
	Chemical resistance	Electric insulation	Low refractive index

Application examples



Device-protection film

CYTOPTM shows a high resistance to acids, alkalis and organic solvents. Coating a device with a thin film of CYTOPTM improves its resistance to those substances.



Ink jet nozzle

CYTOPTM is stable when exposed to ink agents and can be used as a fluid-repellent coating of an ink jet nozzle.



Etching-protection film

With its high resistance to various types of etching chemicals, CYTOP[™] can be used as a protective film in the etching process. It can be easily removed by using a dedicated medium after use.

Chemical resistance of CYTOP[™]

Reagent		Change of weight (%)	Change of appearance	Remark
Acid	35% HCl	0.0	No change	60°C×1week
	96% H ₂ SO ₄	0.0	No change	60°C×1week
	50% HF	0.0	No change	60°C×1week
Alkalin e	10% NaOH	0.0	No change	60°C×1week
	44% NaOH	0.0	No change	60°C×1week
	48% KOH	0.0	No change	60°C×1week
	2.38% TMAH	0.0	No change	60°C×1week
Organic solvent	Hexane	0.0	No change	RT×1week
	IPA	0.0	No change	RT×1week
	Acetone	0.0	No change	RT×1week
	Methyl ethylene	0.0	No change	RT×1week

Test piece ; $20 \times 30 \times 0.2$ mm

RT ; Room Temperature

It shows a high resistance to acids, alkalis and organic solvents.

AGC Chemicals

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